

Form PTO-1449

Docket Number (Cp-000000)

Application Number

tsmc-00-6808

10/696,430

Loopback!

min-Hwa Chi

FDting Date

10/29/03

Group Art Unit

INFORMATION DISCLOSURE CITATION
IN AN APPLICATION

(Use several sheets if necessary)

U. S. PATENT DOCUMENTS

[illegible]

FOREIGN PATENT DOCUMENTS

[illegible]

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

ah	-	"Monolithic IMPATT Technology," by Bayraktaro, in Microwave Journal, April 1989, pp. 73-86.
1	-	
ah	-	"Comparison of GIDL in p+-poly PMOS and n+-poly PMOS Devices," by Lindert et al., IEEE Electron Device Letters, Vol. 17, No. 6, June 1996, pp. 285-287.

EXAMEN

DATE CONSIDERED

Andrew

05/26/54

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.